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PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tsuneyuki OKABE, et al.

U.S. Serial No.: 10/564,558

Group Art Unit: 2812

Filed: : January 13, 2006

Examiner: To Be Assigned

For: SEMICONDUCTOR MANUFACTURING APPARATUS AND
SEMICONDUCTOR MANUFACTURING METHOD

FIFTH INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the attached European Search Report dated September 4, 2007. A copy of the non-U.S. document is enclosed.

Applicants certify under 37 C.F.R. 1.97(e)(1) that all documents submitted herewith were cited in a communication from a foreign patent office in a counterpart foreign application no more than three months prior to the filing of this Statement. Therefore, it is respectfully urged that no fees are required for the Examiner's consideration of the documents listed in this Information Disclosure Statement.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,
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